

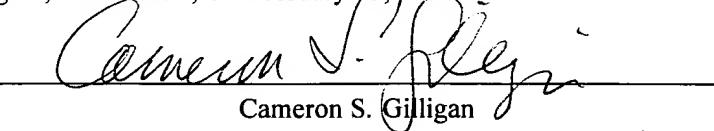


- 1 -

Docket: 0756-1614

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on February 23, 1998.


Cameron S. Gilligan

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Takeshi FUKUNAGA et al.)
Serial No. 08/781,920) Art Unit: 1112
Filed: December 30, 1996) Examiner: M. Padgett
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE)

AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 21, 1997, please amend the subject application as follows.

IN THE TITLE:

Please replace the Title with the following:

--METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

UTILIZING A CATALYST MATERIAL SOLUTION--

IN THE CLAIMS:

Please cancel claims 1-4, 6-15 and 7-23.

19 | F
3-9-98
M. Ross